

FORM PTO-1449 INFORMATION DISCLOSURE CITATION IN AN APPLICATION <i>(Use several sheets if necessary)</i>	Docket Number (Optional) 89285.0007	Application Number 10/537,447
	Applicant IWASAKI, et al.	
	Filing Date March 21, 2006	Group Art Unit 3728

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EXAMINER	DATE CONSIDERED
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	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
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EXAMINER /Adam Krupicka/	DATE CONSIDERED 01/22/2009
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\\LA - 089285/000007 - 3231A11 ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /A.K./